

Docket No.: 060188-0807



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277
Osamu KUSUMOTO, et al. : Confirmation Number: 4190
Application No.: 10/801,606 : Group Art Unit: 2811
Filed: March 17, 2004 : Examiner: HU, Shouxiang

For: SILICON CARBIDE SEMICONDUCTOR DEVICE AND METHOD FOR FABRICATING
THE SAME

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated October 4, 2005, having a three-month shortened statutory period for response set to expire January 4, 2006, please amend the above-identified application as follows.